CERN plans for thin films R&D

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Overview

- Motivation
- FCC planning
- Required SRF performance for FCC-ee
- SRF Challenges
- R&D package towards FCC-ee: milestones & deliverables
- Summary

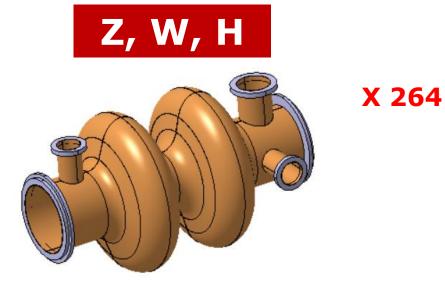


FCC, 91 km long

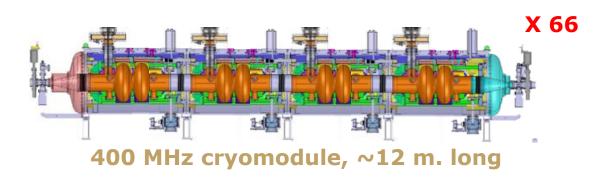
1000

LHC, 27 km long

Two design of superconducting RF cavities



400 MHz 2-cell cavity Niobium thin film on Copper, Operation at 4.5 Kelvin Max. Accelerating gradient $E_{acc} = 13$ MV/m Quality factor $Q_0 = 3.3 \times 10^9$

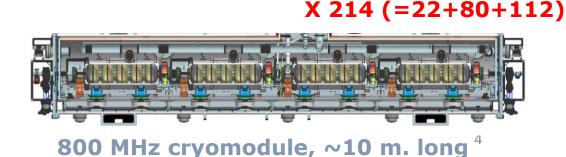


ttb, booster

X 856 (=88+320+448)



800 MHz 6-cell cavity Bulk Niobium Operation at 2 Kelvin Max. Accelerating gradient $E_{acc} = 24.8$ MV/m Quality factor $Q_0 = 3.8 \times 10^{10}$



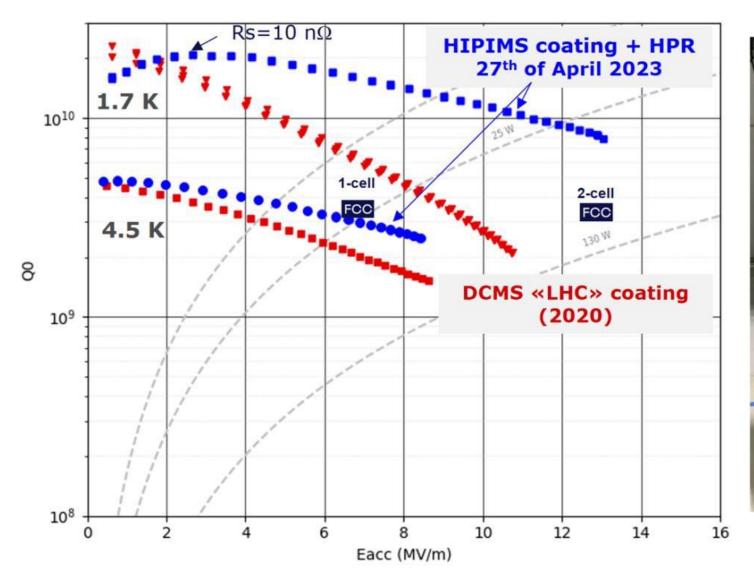
FCC machine specs (surface resistance and peak fields)

Quantity	Booster (800 MHz)	Z (400 MHz, 4K)	W(400 MHz, 4K)	H(400 MHz, 4K)	ttb (800 MHz, 2K)
Q _o	3 10 ¹⁰	2.7 10 ⁹	2.7 10 ⁹	2.7 10 ⁹	3 10 ¹⁰
E _a (MV/m)	6.2→ 20.1	3.8	10.6	10.6	20.1
R _s (av n Ω)	9.1	89	87	87	9.1
B_{peak}(m T)	87.2	20.4	56.6	56.6	87.2
E _{peak} (MV/m)	41.2	8.4	21.2	21.2	41.2

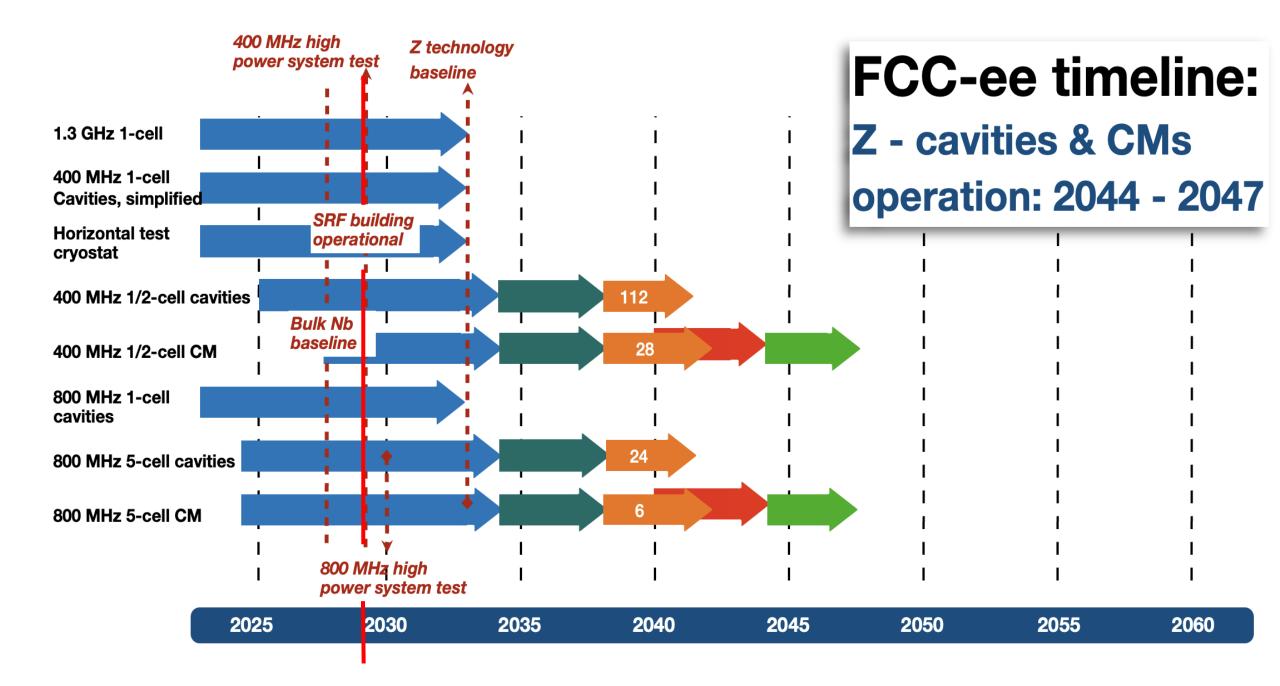
NB: 4K and 2K are indicative

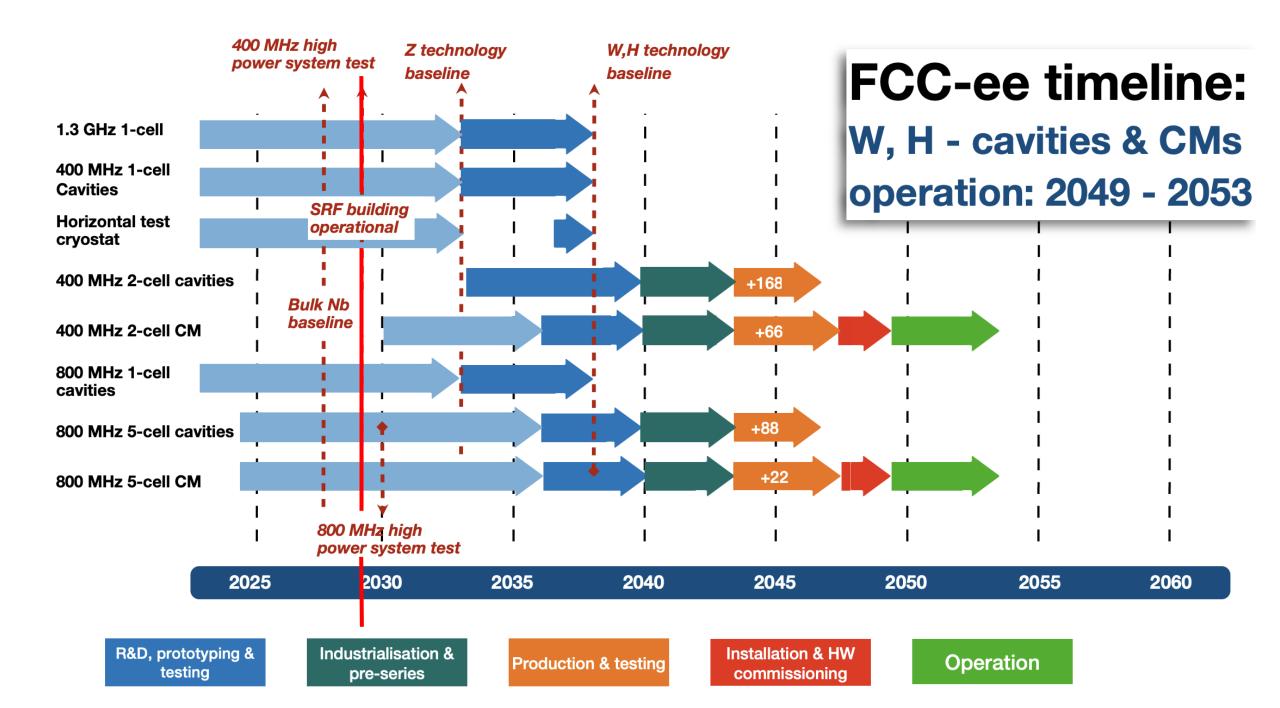
- Compared with state of the art for bulk Nb and Nb/Cu,
 - B_{peak} < 100 mT (no HFQS) in all cases (120 mT demonstrated in Nb/Cu)
 - E_{peak} is quite relaxed
- Fields are limited by RF power: we don't need ultra high fields (x 2 margin to state of the art), except maybe for the booster of the ttb
- But Rs is challenging
- Is 800 MHz with Nb/Cu a possibility? Harder but not so crazy seen the longer time scale
- Challenge staged in time for the collider, booster is pulsed (Q_o may be relaxed?)

State of the art: 400 MHz

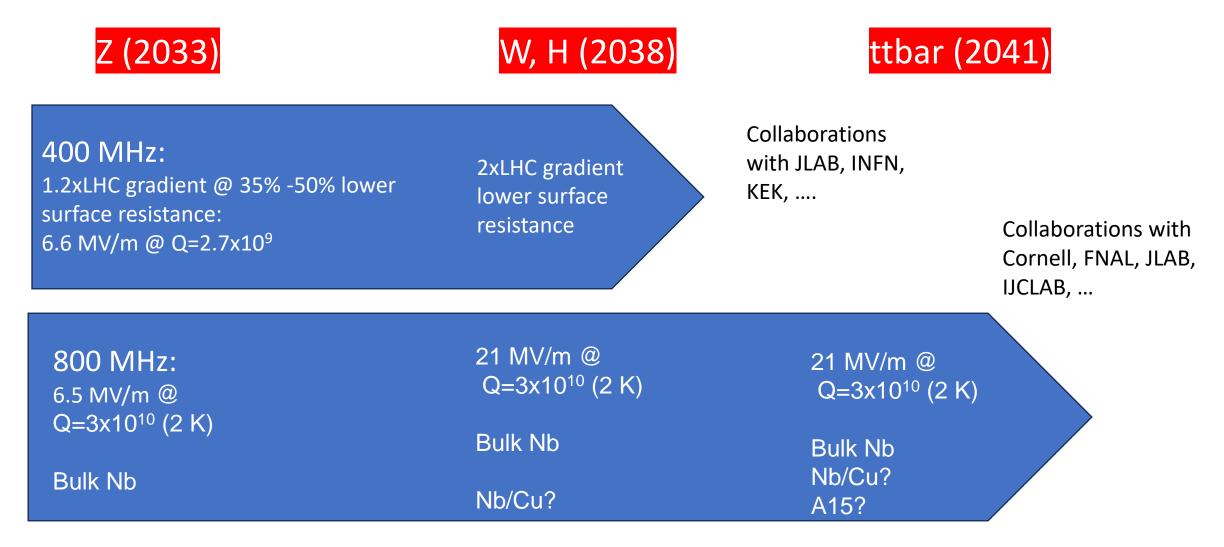








Required performance gains in time for series production





Challenges for CERN SRF teams

Maintain LHC ACS

Recover HIE ISOLDE full energy

Deliver crab systems for HL LHC

New SRF facility: optimise design, organise migration

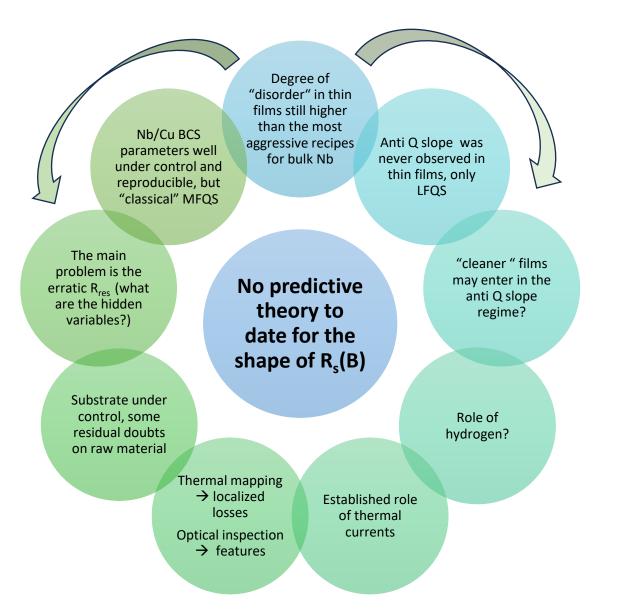
Achieve FCC specs with Nb/Cu for all poles

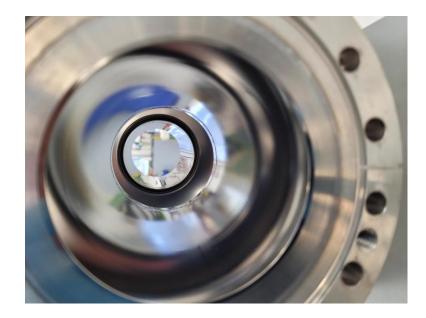
Achieve FCC specs with Nb₃/Sn at 4 K

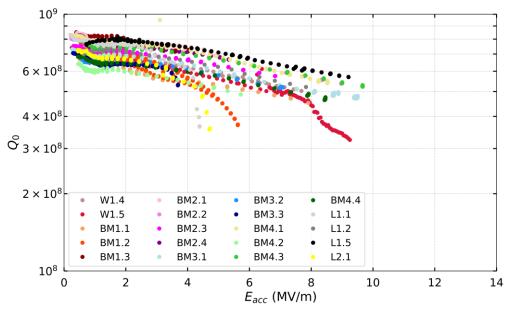
Technology transfer, enable industry for large scale production

Develop and maintain a coherent set of collaborations with other labs

Our first challenge: understand and control $R_s(H)$: Nb thin films







Nb_3Sn

See: G. Rosaz, this conference

- Nb₃Sn on copper would be game changer for next generation of CW accelerators. For FCC:
 - Operation at 4 K saves capital cost
 - 3 10¹⁰ at 2 K corresponds to 7.5 10⁹ at 4 K in plug power: we don't need to equate bulk Nb at 2 K
 - In a second stage, potential to drastically reduce plug power
- Good progress with flat samples, huge challenge: scale the process to a real cavity!
- Decision to focus on 800 MHz
 - Issues: high temperature (700°C) coating system avoiding cavity collapse, multiple cathodes, etc
 - Start from the mechanical design of the cavity
 - Tuning system (FRT?)
 - Conduction cooling for 4.5 K operation?



Technology transfer to industry

A necessity for a large scale production, it must be prepared well in advance Can we start with a survey of potential actors? Can KT be involved at this stage?

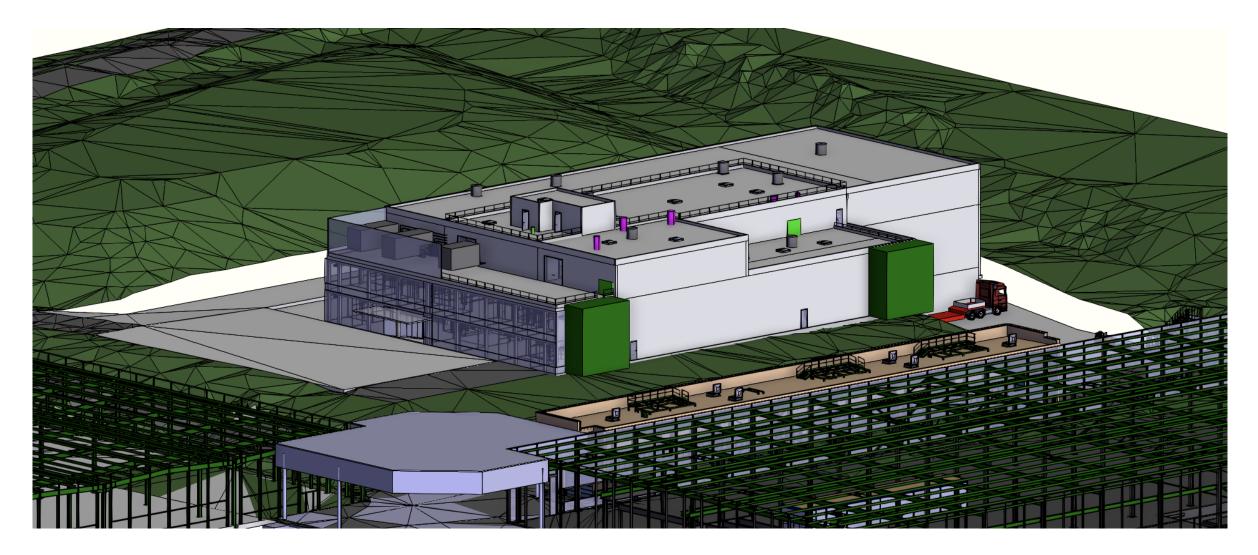
Market survey for Nb and Cu raw material, how frequently updated? Only two companies offer Nb cavities?

Copper cavity production can be stimulated with some small pilot projects Integrating more steps of the Nb/Cu process seems more difficult, but it was done at the time of LEP

SA18 goal: establish reproducible recipes

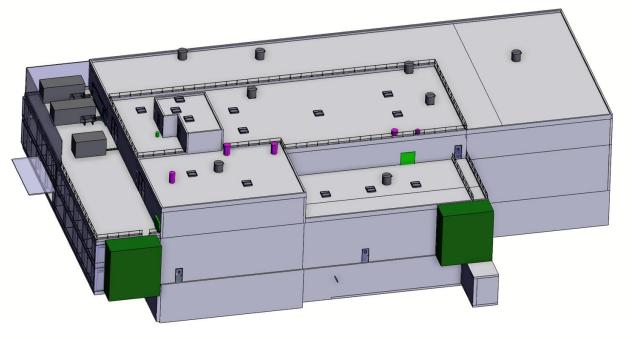
Is a reproducible recipe and a potential for order a large quantity the only possibility to start contacts with industry?

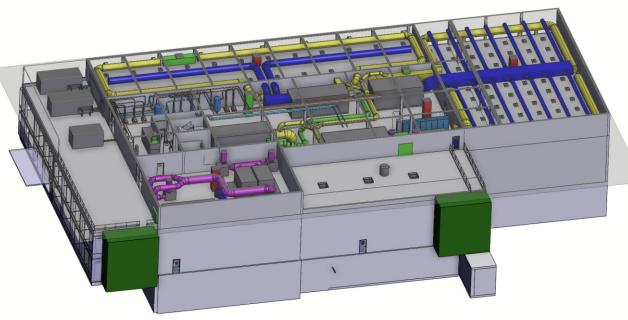
The New SRF Facility: a hub for SRF thin films R&D



Project Schedule

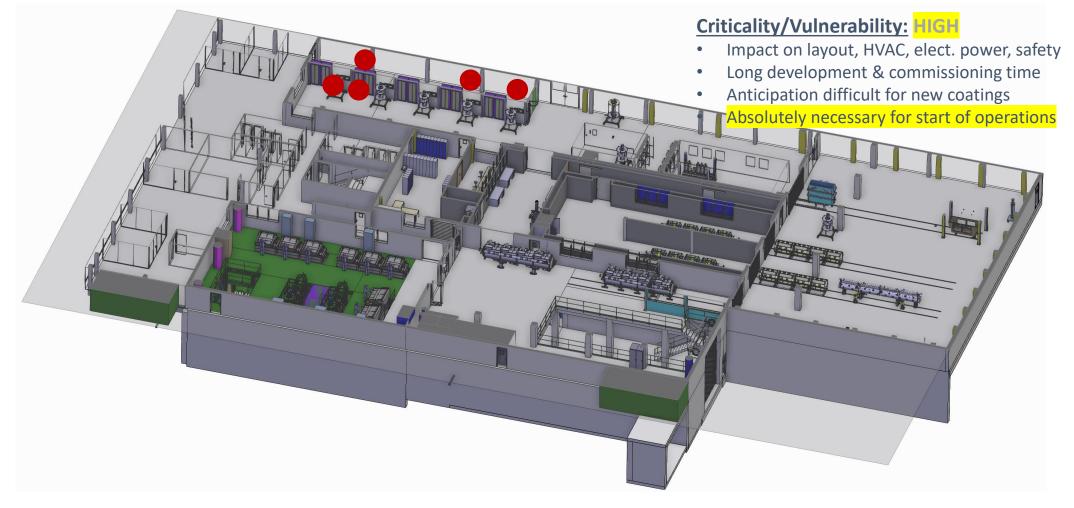
- New facility will be delivered in Q3-2028
- At that stage it will be equipped with:
- A 2MVA main supply
- A 500 kW CV plant to provide:
 - ventilation for the cleanrooms and surface treatment workshop
 - fume extraction and scrubbers for the chemical processes
 - production of chilled water
- All cleanrooms and cleanroom cranes
- Process <u>not yet</u> installed:
 - Electro / chemical polishing stations
 - High pressure rinsing systems
 - Sputtering stations, vacuum oven
 - Waste water treatment plant



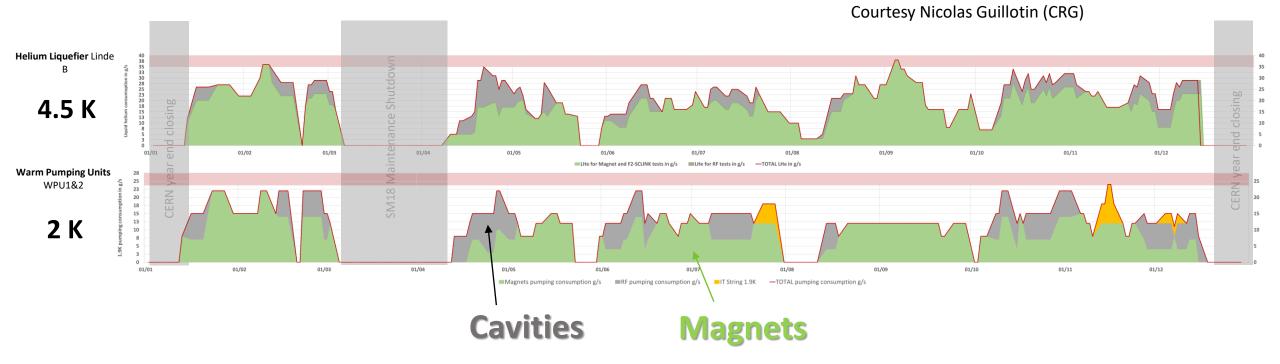


Thin film coating systems

- Still some work to do on the future coating systems:
 - Existing sputtering systems need to be re-designed a.s.a.p. (+ addressing the pros & cons of a mobile cathode system)
 - A15 coating station needs to be addressed urgently to study possible integration
 - Use case of a vacuum oven needs to be identified (processes for bulk Nb, Nb sputtering, A15 coating, ALD require different ovens)



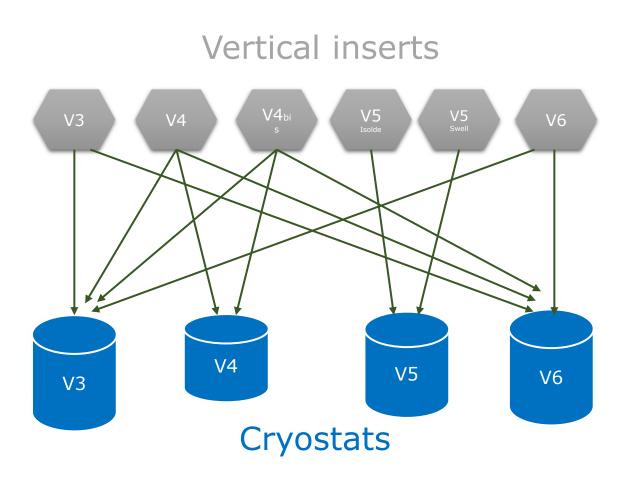
SM18 Cryogenic capabilities – situation in 2023



How can we optimize the cryogenic consumption and benefit from available helium in transitory periods ?

Upgrades of RF cold testing facility







V3 / V6 insert with RFD crab bare cavity ⇒ This will allow to have a stock of prepared cavities "ready to be tested"

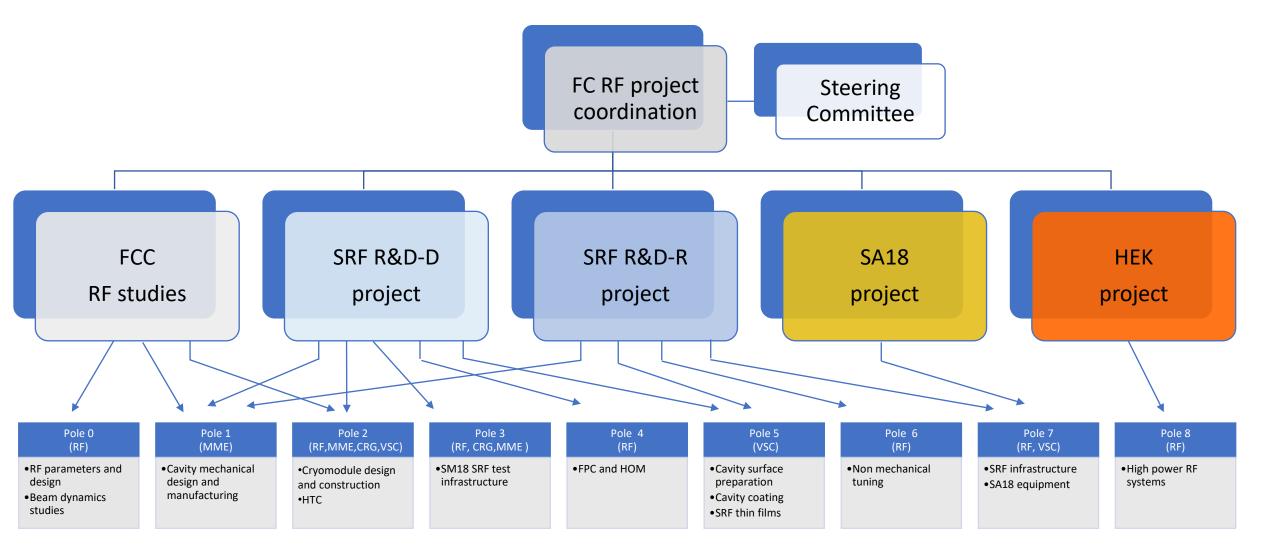
New V4bis insert and preparation area

MTP bid for a dedicated resourse package for (S)RF R&D

- Today resources and infrastructure are booked to keep existing machines running and to secure HL-LHC deliverables
- Additional resources are needed to speed up R/D, and to build hardware (FCC prototypes)
- Proposal prepared at end of 2023 (25 MCHF + 22 new staff)
- Management approved, albeit with 20% cut and smearing over more years
- First posts openings in 2025, in RF, Vacuum, mechanical engineering, cryogenics

Count of Sta Column							
Row Labe 🔽 2025	2	026 2027	Grand Total				
EN	1	2	2	5			
SY	2	2	4	8			
TE	1	1	2	4			
Grand Total	4	5	8	17			

• New structure and governance being implemented



FC RF project coordination and steering committee (GL team), sets goals, defines priorities, monitors progress, reports to ATS Projects manage budgets and follow up activities

Each project/study keeps its internal WBS: this is the list of deliverables, activity plan, spending profile, etc

Poles are centres of activity according to different subjects

One link person per participating Group in each pole, participates to enlarged coordination meetings (few/year)

Project meetings on focused, technical topics, with attendance depending on agenda

New SRF-R&D-D project

- Focused on the Development of prototypes (demostrators)
- Not directly linked to FCC, but under the umbrella of Future Colliders
- WBS and milestones being elaborated

Task/milestone	2024	2025	2026	2027	2028	2029	2030	2031	2032
SA18 facility operational						*			
HTC operational in SM18 (TBD)			*						
400 MHz CM Demo (2-cell) ready for testing (TBD)									
Horizontal Test Cryostat (HTC) in M9	Design	Construction	inst.+test				, j	T	
400 MHz CM Demo (2-cell)									
Cryomodule Design Conceptual Design		Detaile	d Design		+				
Cryomodule manufacture					Construction				
Assembly (in SA18)							Assembly		
2-cell cavities (x4) tested						•			
RF design									
Mech. Design									
Manufacture									
Coating									
Bare vertical testing									
FPC (x4) & HOMs (x12) tested									
RF design									
Mech. Design									
Manufacture									
Conditioning & warm testing									
Helium tanks/tuning system (x4) ready									
Mech. Design									
Manufacture									
Dressed cavities/FPC/HOM assemblies (x4) ready									
Assembly									
Vertical testing of dressed cavity with HOMs									
HTC testing with FPC and tuning system									

Summary: CERN strategy for SRF thin films

- Ramping up respources and infrastructure for SRF
- Pursue fundamental R&D on Nb/Cu with 1.3 GHz program (see K. Brunner, this confernece)
 - Low field BCS parameters optimized and reproducible
 - Tackling erratic R_{res}
 - Control T gradient at T_c, stabilize cool down protocol
 - This will allow investigate what hides behind (at least one second hidden var)
 - Develop technology for mass scale production of copper substrates
 - Potential spin off: Nb/Cu at 800 MHz
- Immediate focus on Nb/Cu 400 MHz to reach FCC specs
 - Finalise surface preparatiion method (EP is baseline)
 - Improve cleanliness chain (especially surface prep before coating) \rightarrow New SRF building
 - Dedicated cold test cryostat, mutuate cooling protocol from 1.3 GHz
- New SRF R&D D project to deliver key facilities (HTC) and cryomodule demonstrators
- In parallel, develop Nb₃Sn/Cu at 800 MHz as longer term, further step
- We are open and actively pursuing collaborations with other labs on these topics

SPARE SLIDES

22-Aug-24	Bare cavity in vertical test		Equipped cavity (with HOM couplers) in vertical test		Cryomodule (with FPC) in horizontal test		Operation in the machine	
	Eacc (MV/m)	Q0	Eacc (MV/m)	Q0	Eacc (MV/m)	Q0	Eacc (MV/m)	Q0
2-cell 400 MHz	13.0	3.3E+09	12.4	3.15E+09	11.8	3.0E+09	10.6	2.7E+09
6-cell 800 MHz	24.8	3.8E+10	23.6	3.65E+10	22.5	3.5E+10	20.25	3.0E+10

